TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

| Title of Invention | [THIN FILM TRANSISTOR MANUFACTURE METHOD] |
|------------------------|---|
| Application Number | : |
| Date : | |
| First Named Applica | nt: Mr. Yu-Chou Lee |
| Confirmation Number | er: |
| Assessed Developed No. | |

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| Submitted By: | Elec. Sign. | Sign. Capacity |
|--|---------------|----------------|
| Dr. Belinda Lee Registered Number: 46,863 | /Belinda Lee/ | Agent |

| Documents being submitted: | Files |
|----------------------------|----------------------------|
| us-request | 8991-CP-usregu.xml |
| 30 104000 | us-request.dtd |
| | us-request.xsl |
| us-fee-sheet | 8991-CP-usfees.xml |
| | us-fee-sheet.xsl |
| | us-fee-sheet.dtd |
| us-declaration | 8991declaration1.tif |
| application-body | 8991-CP-trans.xml |
| | us-application-body.xsl |
| | application-body.dtd |
| | wipo.ent |
| | mathml2.dtd |
| | mathml2-qname-1.mod |
| | isoamsa.ent |
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| | 8991us0023.tif |
| | 8991us0024.tif |
| us-declaration | 8991declaration2.tif |

Comments

Please be kindly advised that the indicated fees of this EFS application is intended to be paid by credit card. However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to charge the required fees in connection with this application to: Deposit Account No. 50-2620 (Order No. 8991-US-PA-0C), Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name: Belinda Lee, E-mail: belinda@ciparoup.com.tw. usa@ciparoup.com.tw.